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PATENT APPLICATION

JC978 U.S. PRO  
10/039333  
11/09/01

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of

Gene H. LEE et al.

Serial No. filed herewith

Group Art Unit:

Filed: herewith

Examiner:

For: Method for Etching Tungsten  
Using  $\text{NF}_3$  and  $\text{Cl}_2$

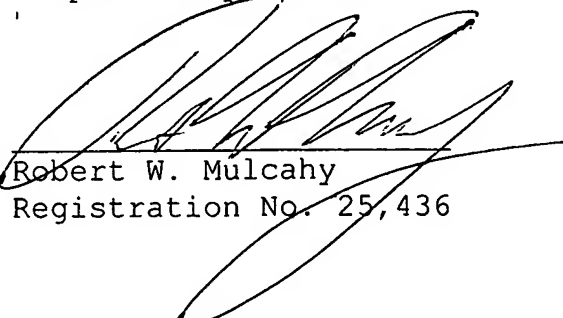
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INFORMATION DISCLOSURE STATEMENT UNDER 37 C.F.R. § 1.97  
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Hon. Commissioner for Patents  
Washington, D.C. 20231

Dear Sir:

In accordance with 37 CFR § 1.56, Applicant hereby submits the following Information Disclosure Statement. The form PTO-1449 submitted, lists references that the Examiner may consider to be relevant. These documents are not necessarily analogous art. Applicant respectfully requests that the Examiner consider these documents, and that the Examiner indicate consideration of the cited references by returning a signed copy of the attached form PTO-1449. Copies of all the cited references are enclosed.

Respectfully submitted,

  
Robert W. Mulcahy  
Registration No. 25,436